



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 4, 2026	
IGI Report Number	LG787674952
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	12.04 X 5.76 X 3.76 MM

GRADING RESULTS

Carat Weight	1.49 CARAT
Color Grade	E
Clarity Grade	VS 1

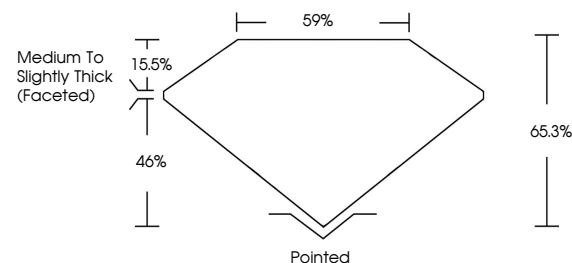
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG787674952

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

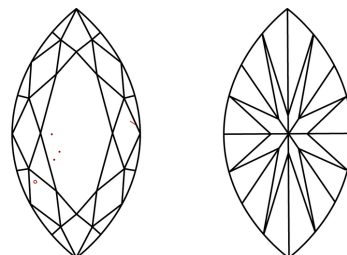
LG787674952
Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

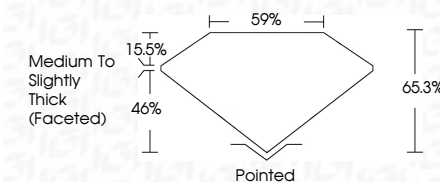
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www.igi.org

April 4, 2026
GJ Report No | G787674952

GI Report No 16781674952	1.49 CARAT
VS 1	
65.3%	
59%	
Medium to Slightly Thick Faceted	
Pointed	
EXCELLENT	
EXCELLENT	
NONE	
Serial 16781674952	

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(CVD) growth process.